## Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination
10607020	HILL ET AL.
Examiner	Art Unit
Le Nguyen	2174

SEARCHED					
Class	Subclass	Date	Examiner		
715	752, 963	11/13/07	lvn		
715	752, 963	2/25/2009	lvn		
715	752, 963	6/17/2009	lvn		
715	752, 963	12/30/2009	lvn		

SEARCH NOTES				
Search Notes	Date	Examiner		
confirmed allowance w/Sy Luu	6/21/07	lvn		
US-PGPub, USPAT: 715/751-753; 709/204-207	11/13/07	lvn		
EPO, JPO	11/13/07	lvn		
ACM library, IEEE Xplore	11/13/07	lvn		
confirmed allowance w/Raymond Bayerl	6/25/07	lvn		
confirmed allowance w/Steve Sax	11/26/07	lvn		
updated search	2/25/2009	lvn		
updated search	6/17/2009	lvn		
updated search	12/30/2009	lvn		

INTERFERENCE SEARCH					
Class	Subclass	Date	Examiner		
715	752, 963	11/13/07	lvn		
715	752, 963	2/25/2009	lvn		
715	752, 963	6/17/2009	lvn		
715	752, 963	12/30/2009	lvn		

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